Application No. SHIGA7.047APC INFORMATION DISCLOSURE Filing Date 10/574,073 First Named Inventor Watanabe, et al. STATEMENT BY APPLICANT Art Unit 1752 (Multiple sheets used when necessary) Examiner Amanda C. Walke Attorney Docket No. SHEET 1 OF 2 SHIGA7.047APC

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Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear		
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	7	JP 2003-177537 (Abstract Only)	06-27-2003	FUJI PHOTO FILM CO LTD		1
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T¹ - Place a check mark in this area when an English language Translation is attached.

PTO/SB/08 Equivalent

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Application No. SHIGA7.047APC

Filing Date 10/574,073

First Named Inventor Watanabe, et al.

Art Unit 1752

Examiner Amanda C. Walke

Attorney Docket No. SHIGA7.047APC

(Multiple sheets used when necessary)
SHEET 2 OF 2

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Examiner Initials	Cite No.	Foreign Patent Document Country Code-Number-Kind Code Example: JP 1234567 A1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear	T ¹
	19	EP 0562819 A2	09-29-1993	Murata, et al.		

NON PATENT LITERATURE DOCUMENTS				
Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ¹	

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